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## APPLICATION DATA SHEET

Electronic Version v14 Stylesheet Version v14.0

> Title of Invention

PREDICTING DEFECT FUTURE EFFECTS IN INTEGRATED CIRCUIT TECHNOLOGY DEVELOPMENT TO FACILITATE SEMICONDUCTOR WAFER LOT DISPOSITION

Application Type:

regular, utility

Attorney Docket Number:

H0897

Request Not To Publish

I/We hereby request that the attached application not be published under 37 U.S.C. 122(b).

I/We hereby certify that the invention disclosed in the attached application has not and will not be the subject of an application filed in another country, or under a multilateral agreement, that requires publication at eighteen months after filing.

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